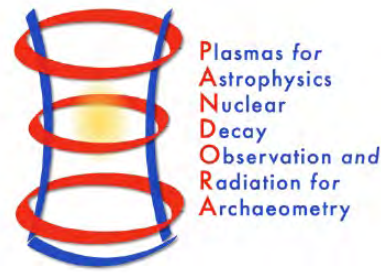


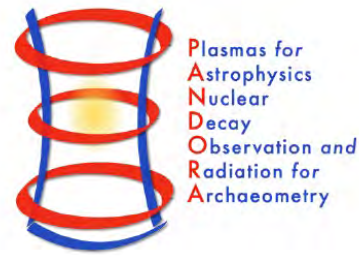
# The PANDORA active Plasma Inner Chamber (PIC) Status update



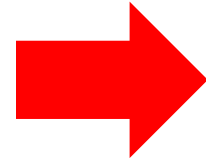
## OUTLINE:

- Physics motivations for an «Active» Plasma Chamber in ECR ion traps (or sources)
- Design and test of a reduced scale prototype (~1:3) for the AISHa ECR ion source @ LNS
- Inner Chamber design options for the PANDORA apparatus
- Next activity & Timelines

# Physics motivations for an Active Plasma Chamber



- GOAL: maximize the mean ion charge state  $\langle q \rangle$ . This is proportional to the ion lifetime in plasma**



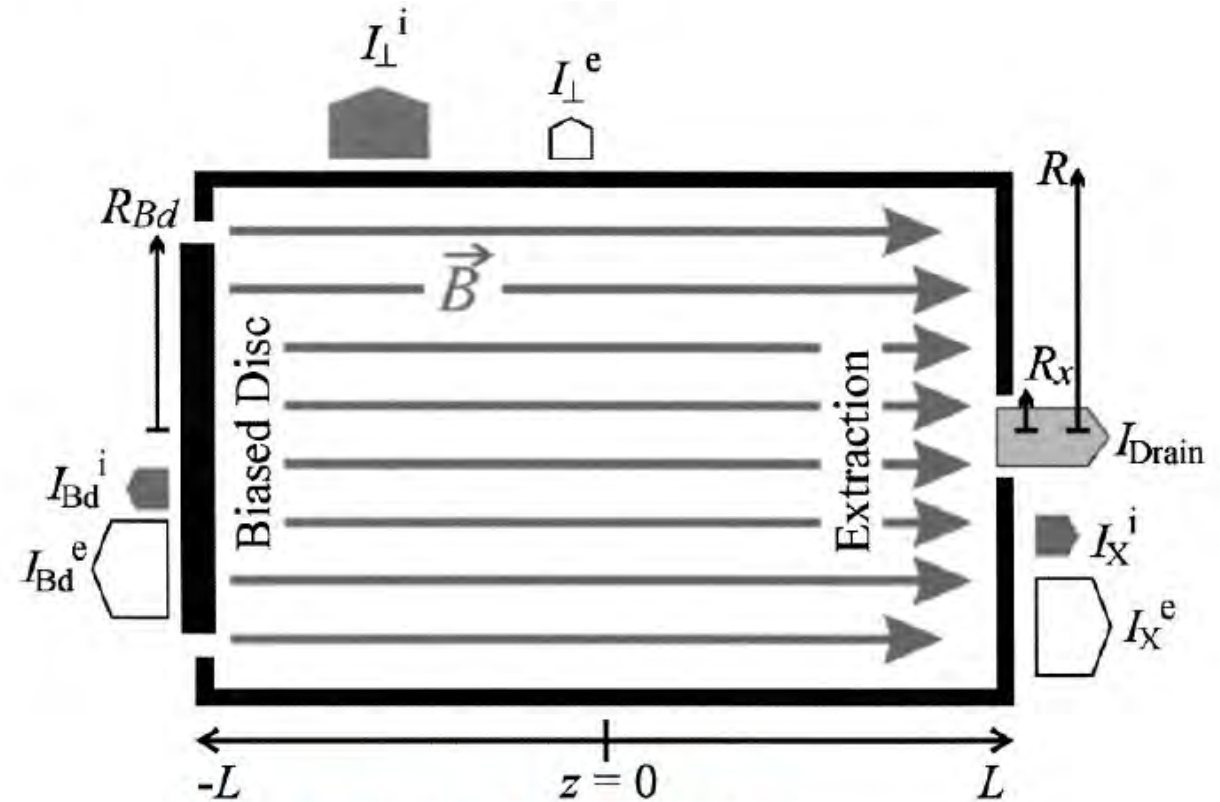
We must **reduce plasma losses** that are due to unavoidable imperfections in the magnetic trap

**electrons**  
are mainly  
lost **axially**

$I_X^e > I_X^i$

**ions**  
are mainly lost  
**radially**

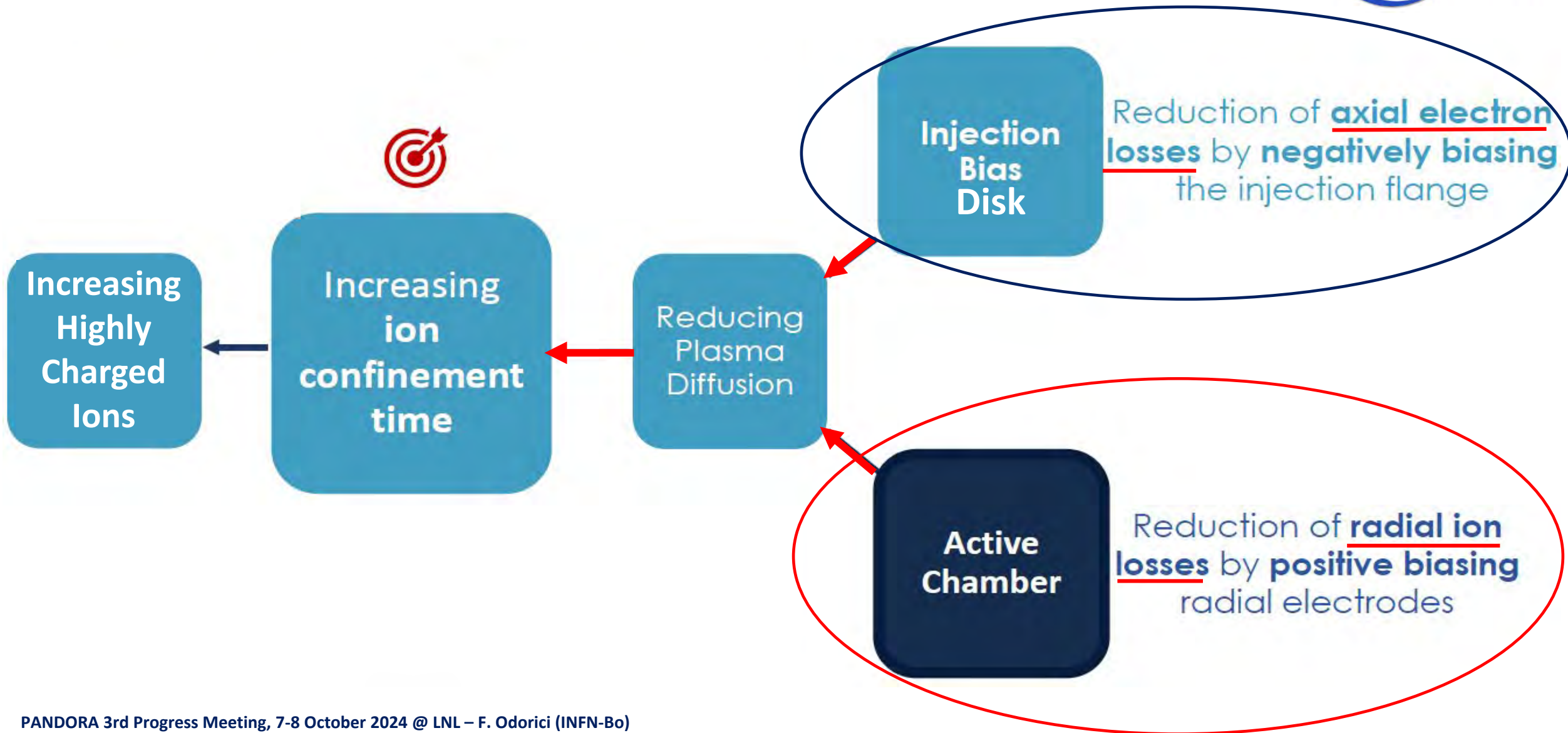
$I_{\perp}^i > I_{\perp}^e$



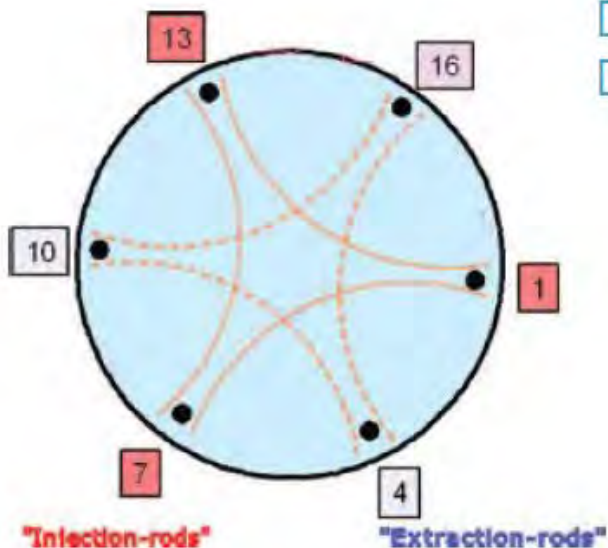
From the **quasineutrality** of the plasma:

$$I_{\perp}^i + I_{\perp}^e + I_{Bd}^i + I_{Bd}^e + I_X^i + I_X^e + I_{Drain} = 0$$

# How to reduce plasma losses



# Active Plasma Chambers in previous experiments

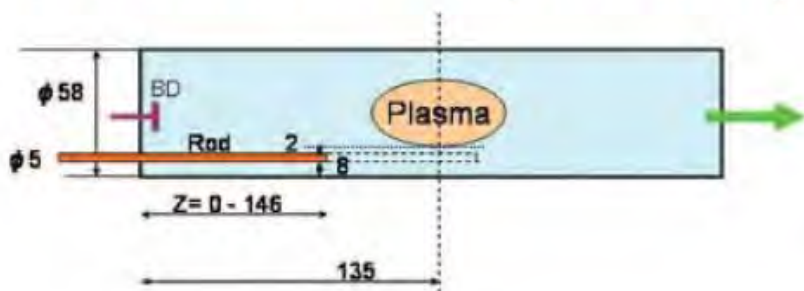


Drentje, A. et al. IEEE Transactions on Plasma Science 36, 1502-1506 (2008)  
Drentje, A. et al. RSI. 85. 02A921 (2014)

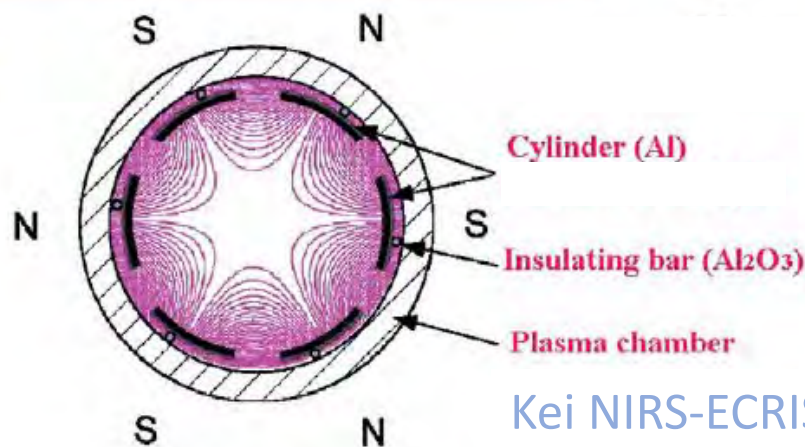
+

Performance improvement: 35-40%	Short Circuit, Melting
---------------------------------	------------------------

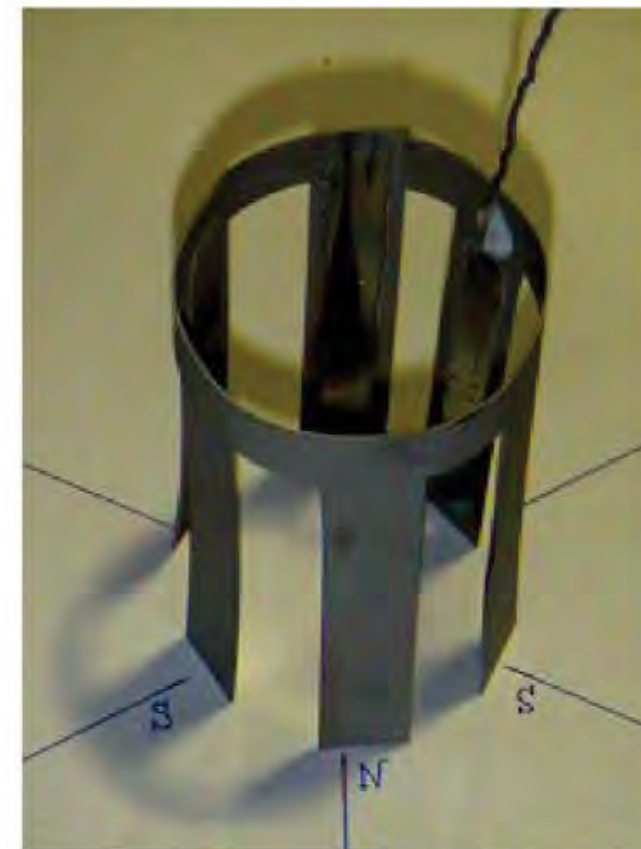
BioNano-ECRIS @ Toyo University (JAP)



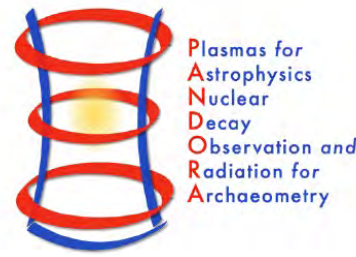
Atomki ECRIS @ Debrecen (Hungary)



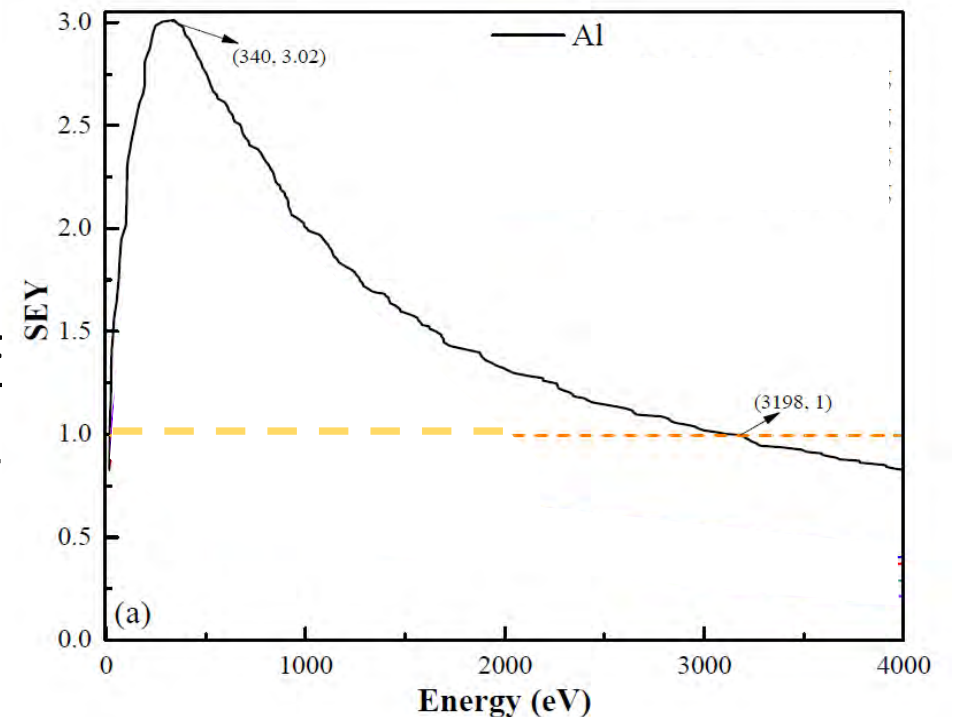
Kei NIRS-ECRIS @ Chiba (Japan)



# Benefits from a Plasma Inner Chamber



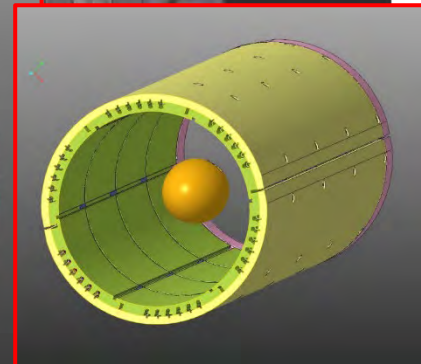
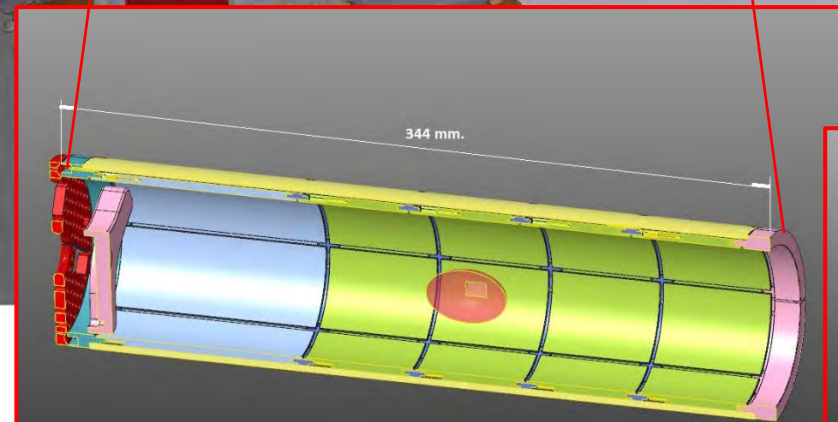
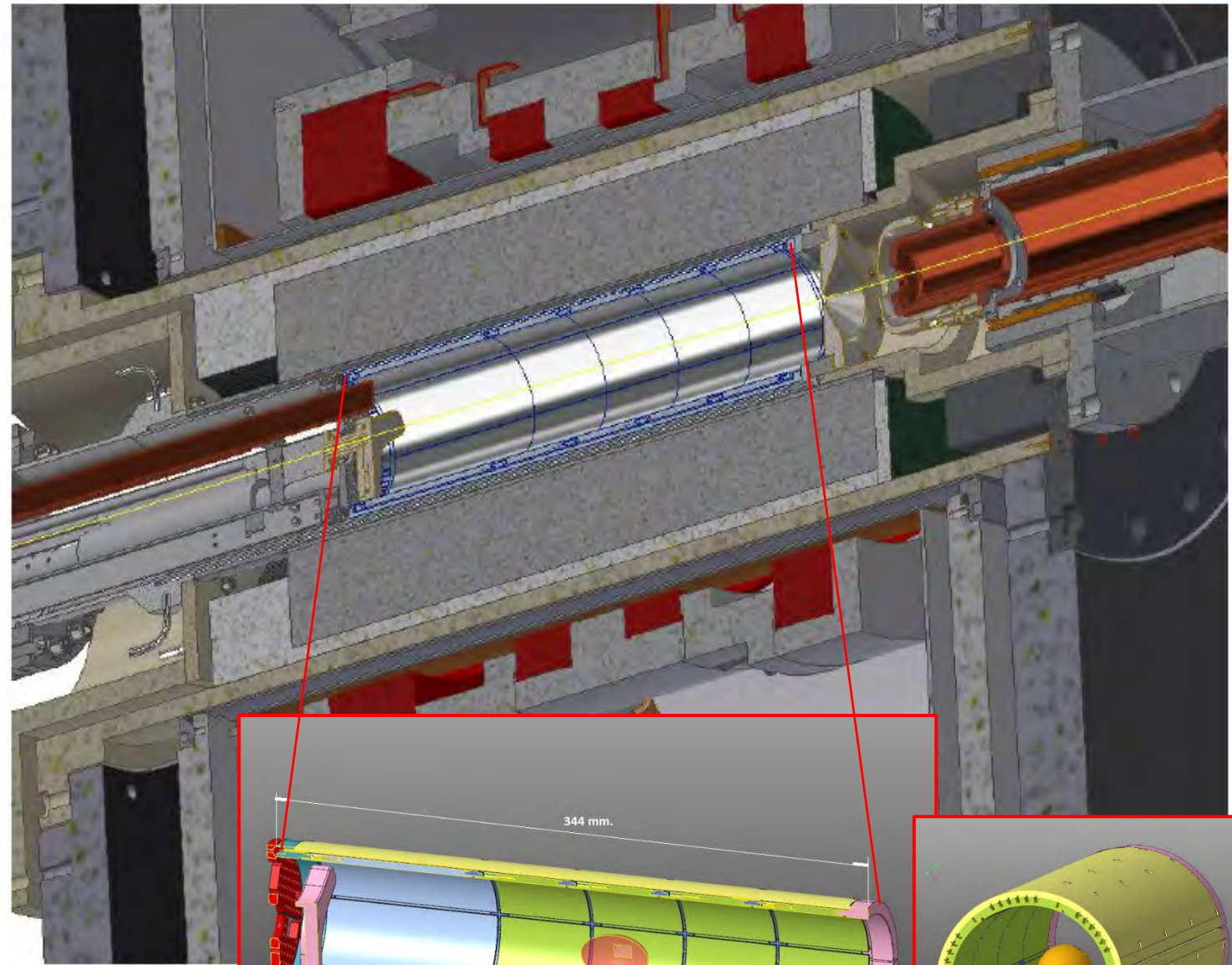
1. Reduce radial ion losses with an **active control** of each tile bias; could have an automatic search for the best bias map, for any PANDORA working condition (pressure, RF, etc)
2. Real-time **monitoring of plasma losses** (detect/avoid **unstable working points**)
3. The **replacement of the inner chamber** can be done in a relative «short time», allowing to remove chamber contamination from radioactive isotopes (switch to a new physics case)
4. Aluminum chamber gives a **Secondary Electron emission Yield (SEY) greater than 1 for a large energy range (< 3.2 keV) of impinging electrons**  
→ permits to operate with lower pressure and RF power, thus limiting charge exchange process and recombination's in the plasma, important to produce highly charged ions.



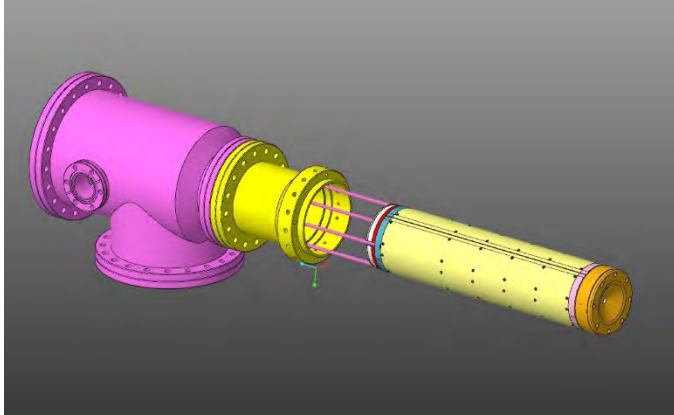
# Prototype of an Active Plasma Chamber for the AISHa ECRIS @ LNS

Developed under the **IONS experiment (CSN5)**:

- Segmentation into 30 «tiles» (5 axial x 6 radial electrodes) of Aluminum-6082
- Electrical insulation among tiles (anodization)
- Positive bias (20 ÷ 50V)
- Efficient cooling
- Temperature measurements
- **Current measurement on each tile (ion losses), via the bias channel**



# Active Plasma Chamber: prototype construction



## Critical aspects:

- Electrical insulation
- Wiring @ high T
- Efficient cooling



## Electrical insulation of tiles and rings: nano-porous anodization

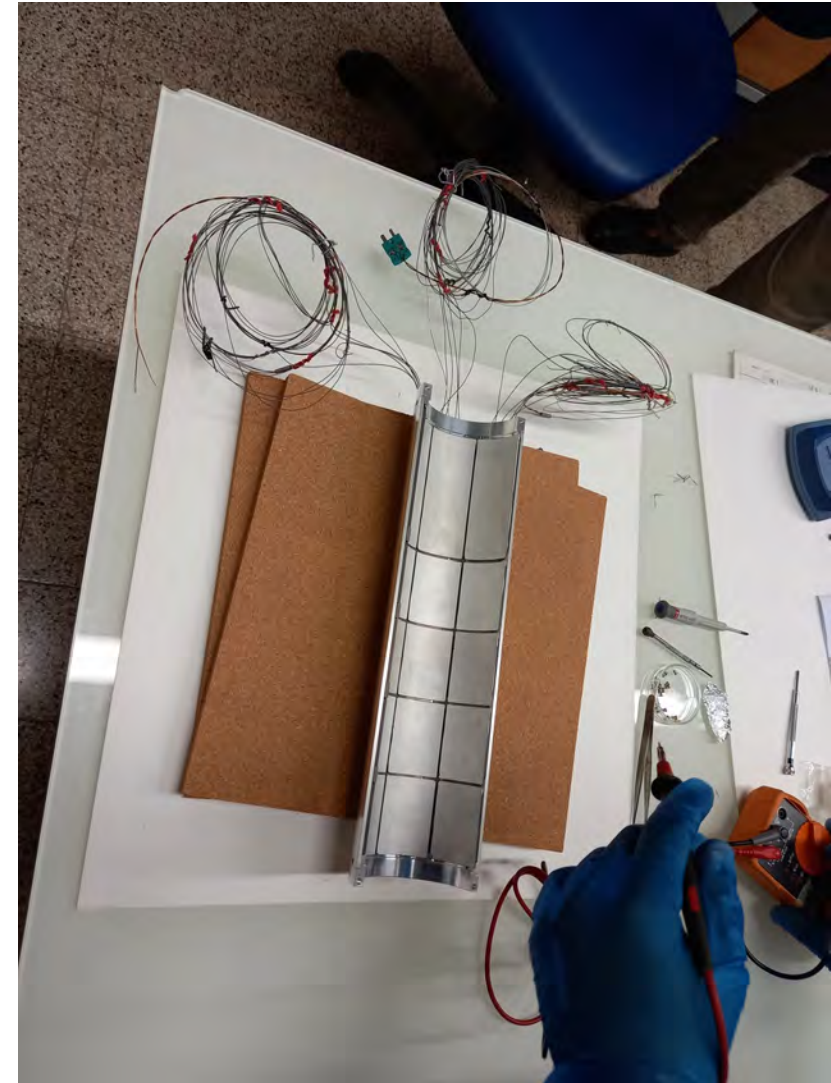


Tiles' internal view (conductive aluminum)

Tiles' external view (anodized Al, 50  $\mu\text{m}$  thick oxide)

## Assembling & wiring

Cu/Ni wires diam. 0.5 mm with ceramic insulation + thermocouples diam. 0.5mm for T monitoring





# Tests of the prototype of the Active Plasma Chamber

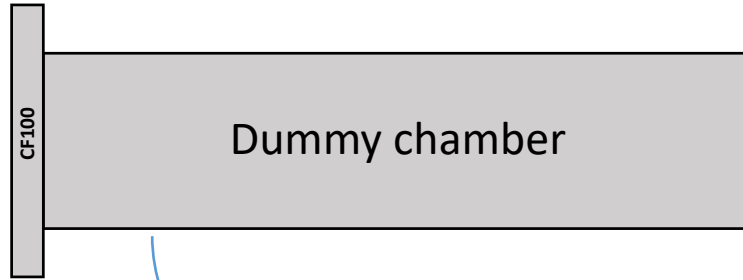
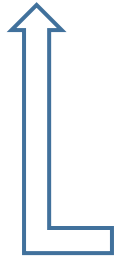
- Test planned on AISHa in 2022 has been postponed to early 2025, as the installation of AISHa in the new experimental room has been delayed for almost 2 years.
- To mitigate the effects of this delay, a pre-test of the Active Chamber prototype has been conducted at the Bologna Section in **2023 & 2024 using a dummy chamber** identical to that of AISHa, specially built for this purpose.
- Test sessions in sep 2023, jan 2024
- Tests conducted so far:
  - mechanical coupling with the dummy chamber;
  - operate @ different temperatures with external baking + halogen lamp (along the chamber axis) to emulate the plasma heat;
  - measure outgassing in vacuum;
  - electrical behaviour.



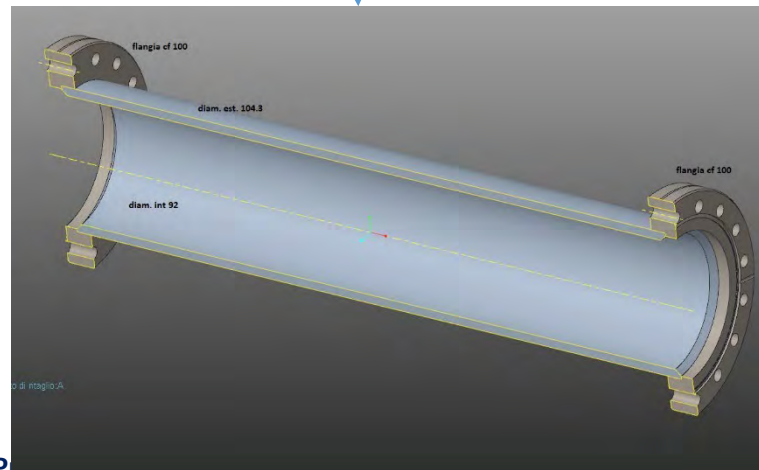
Istituto Nazionale di Fisica Nucleare

# Test SETUP @ Bologna

Pumping system (turbo on CF100 or KF40, primary pump, dual range gauge, controller ...)



Dummy chamber



feedthrough sub-D25, flange CF40



CF40



Passante sub-D25, flangia CF40

CF40

CF40

CF40

CF40

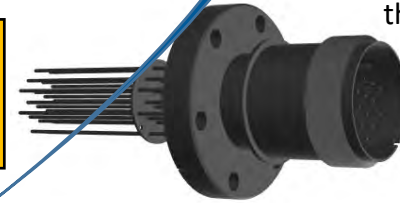
CF40

CF40

Dual range gauge, CF40

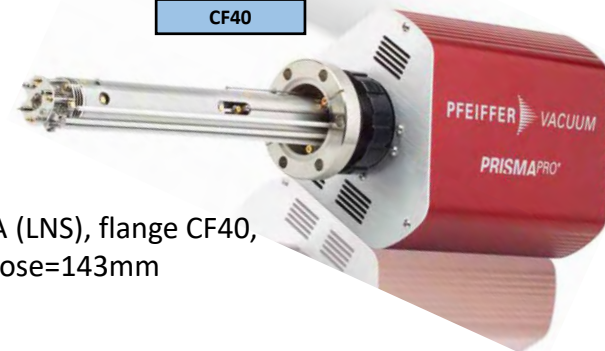


Feedthrough MS x 6 thermocouples K-type, flange CF40 Lpin=92mm

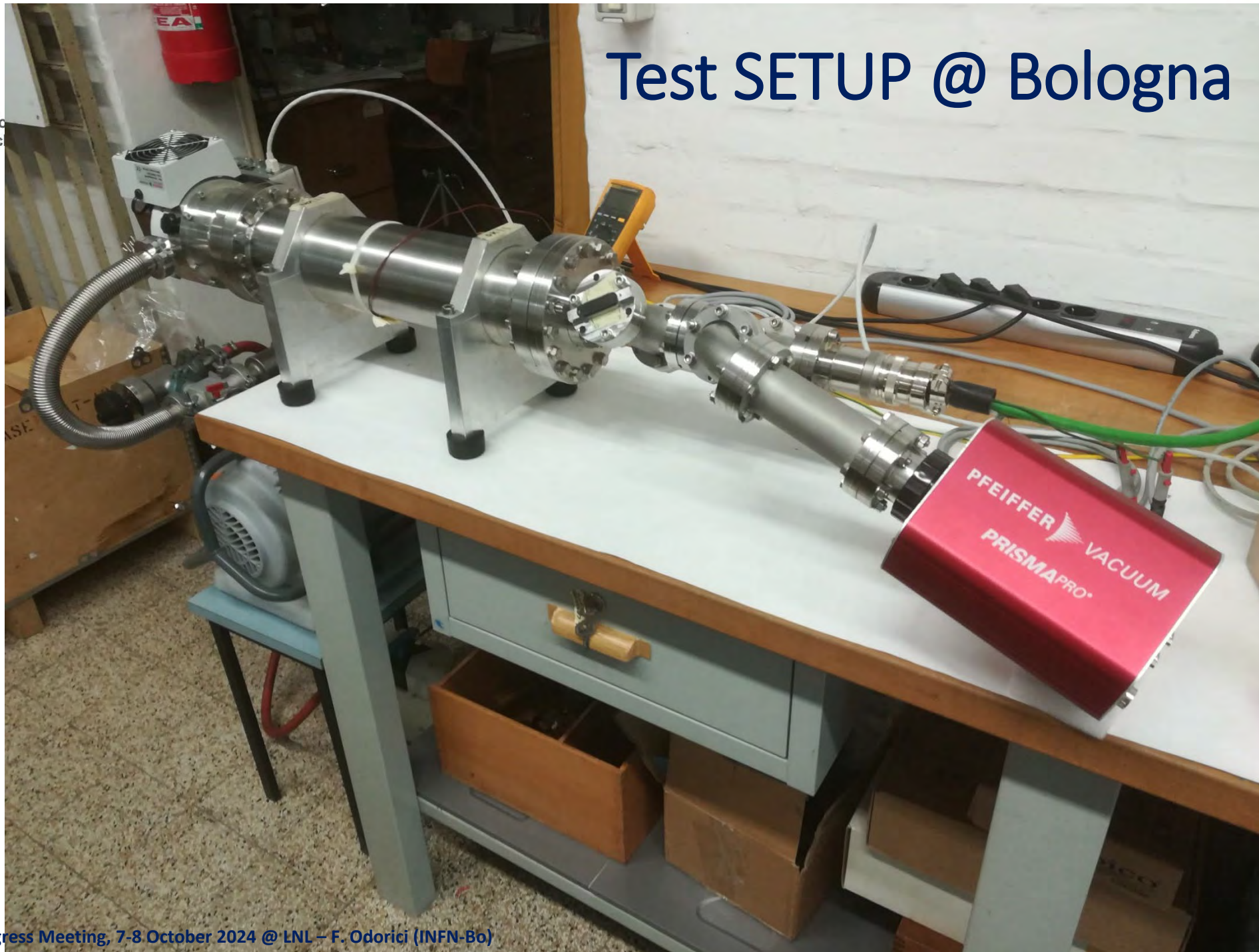


TC datalogger PICO, 8 ch

RGA (LNS), flange CF40, Lnoose=143mm



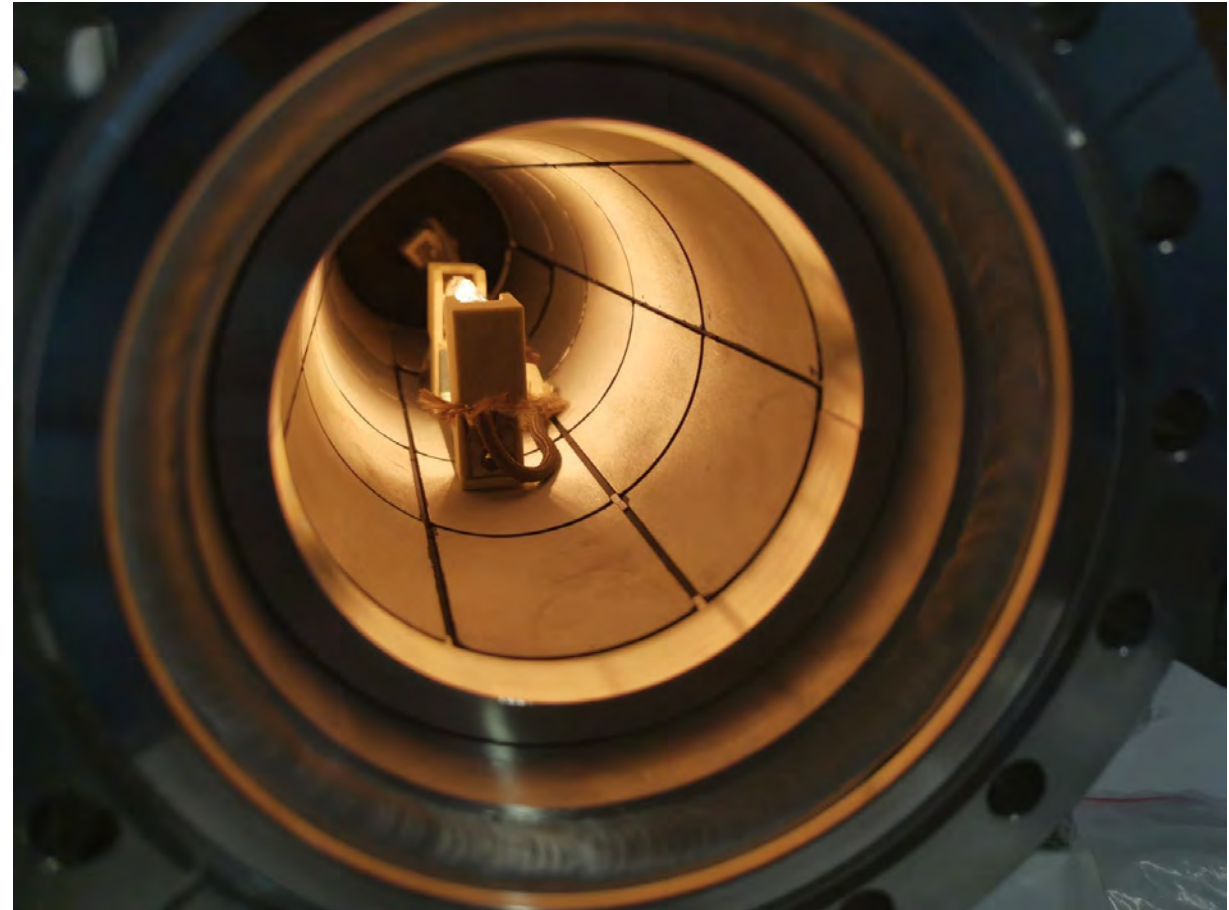
# Test SETUP @ Bologna



Dummy Chamber to emulate  
the AISHa main chamber



Insertion of the Active Chamber into  
the dummy chamber + halogen lamp  
to emulate the plasma radiation heat



# Baking with halogen

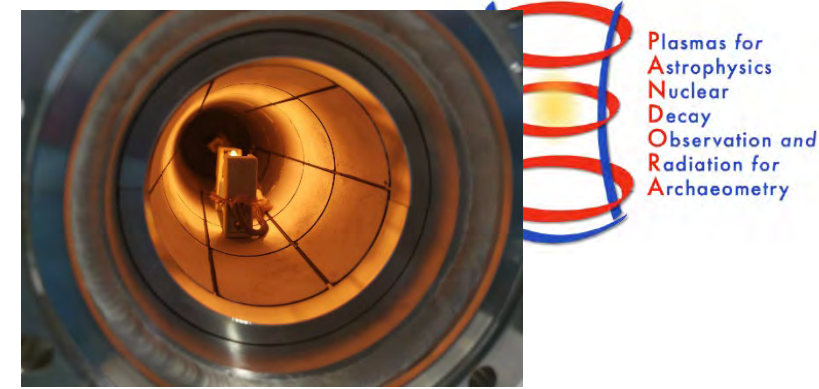
Monitoring of 6 thermocouples on different tiles

Upper shell – inner view

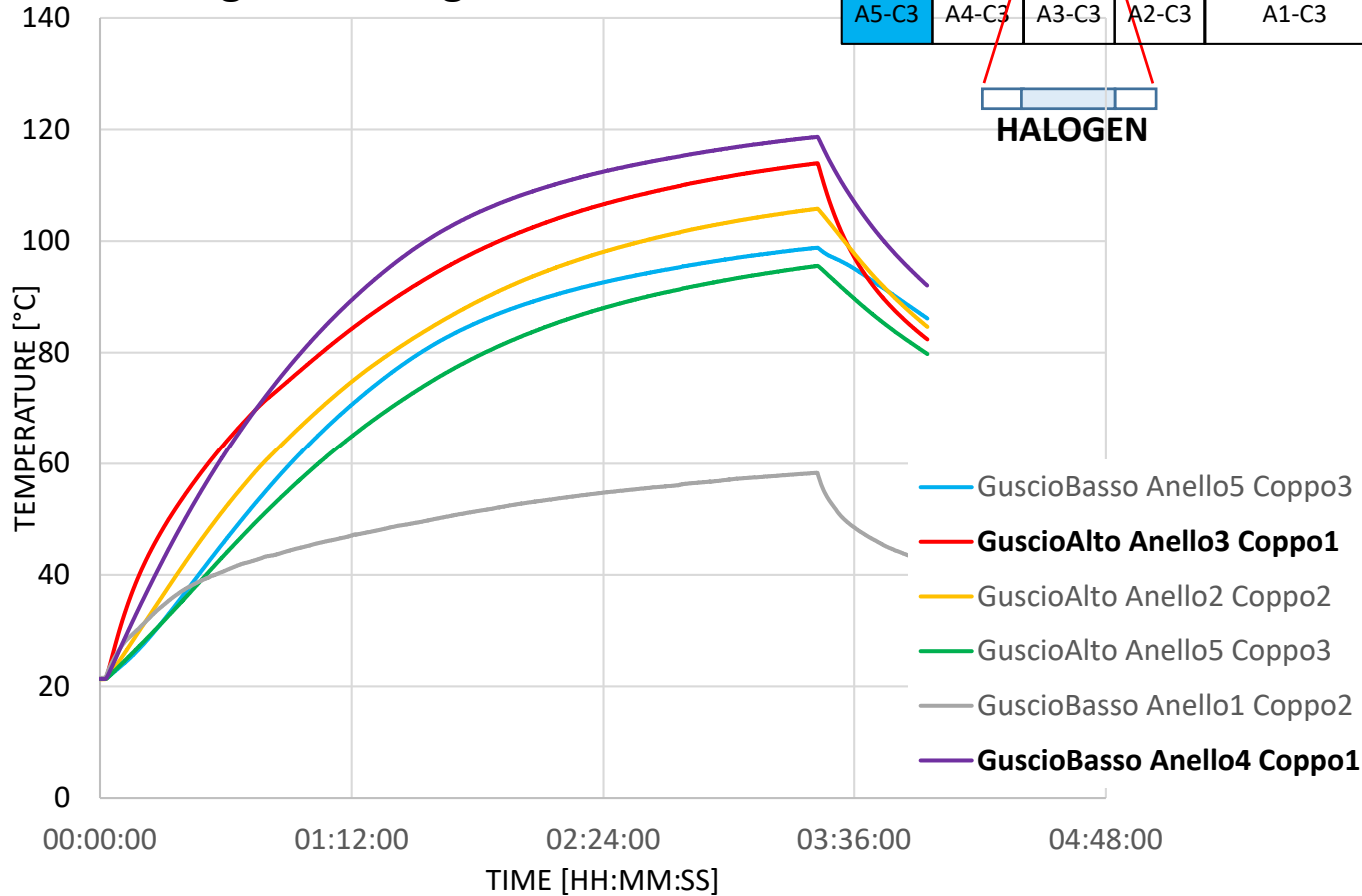
A5-C1	A4-C1	A3-C1	A2-C1	A1-C1
A5-C2	A4-C2	A3-C2	A2-C2	A1-C2
A5-C3	A4-C3	A3-C3	A2-C3	A1-C3

Lower shell – inner view

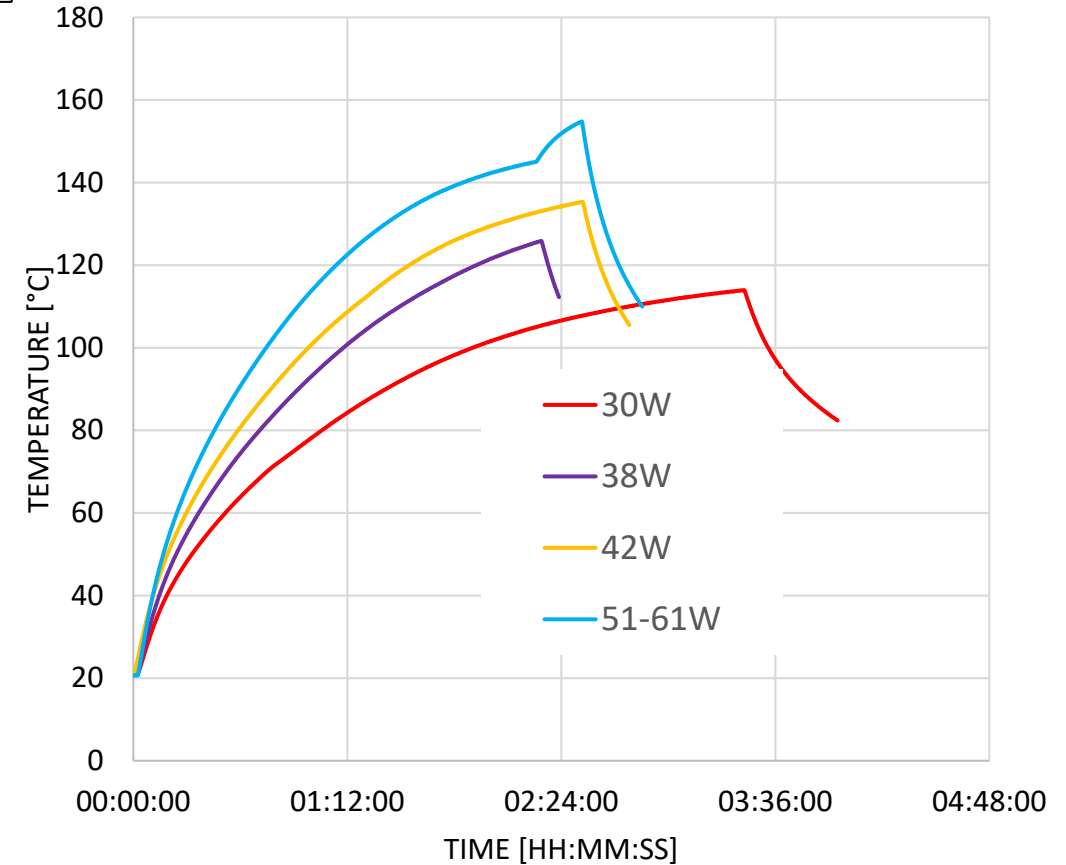
A5-C1	A4-C1	A3-C1	A2-C1	A1-C1
A5-C2	A4-C2	A3-C2	A2-C2	A1-C2
A5-C3	A4-C3	A3-C3	A2-C3	A1-C3



Baking with halogen @ 30W



Upper shell - Ring3 - Tail1 @ various W



# Baking and outgassing tests

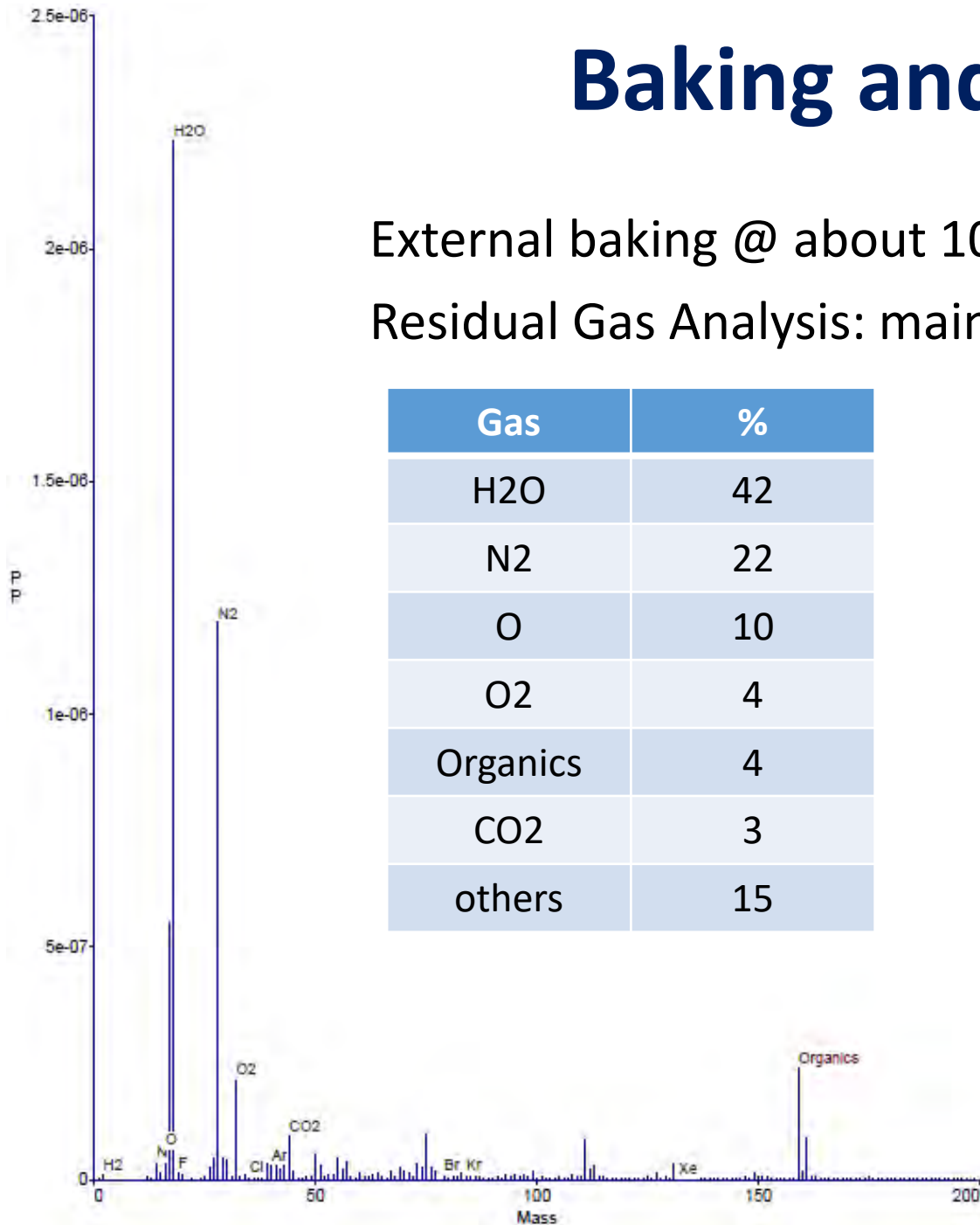
External baking @ about 100°C for 30'

Residual Gas Analysis: main outgassing @  $P=1 \times 10^{-5}$  mbar

Gas	%
H2O	42
N2	22
O	10
O2	4
Organics	4
CO2	3
others	15

Pressure (mbar):

- $1 \times 10^{-4}$  in 90'
- $7.4 \times 10^{-6}$  after 17h
- Internal baking with halogen @ 77W
  - ➔  $8.6 \times 10^{-4}$  @ **tail Tmax 212°C**
  - ➔  $4.0 \times 10^{-6}$  @ T ambient



# Pressure after baking at various power

Pressure after baking at various halogen power, after cooling at ambient temperature with pumping off, followed by pumping for about 20':

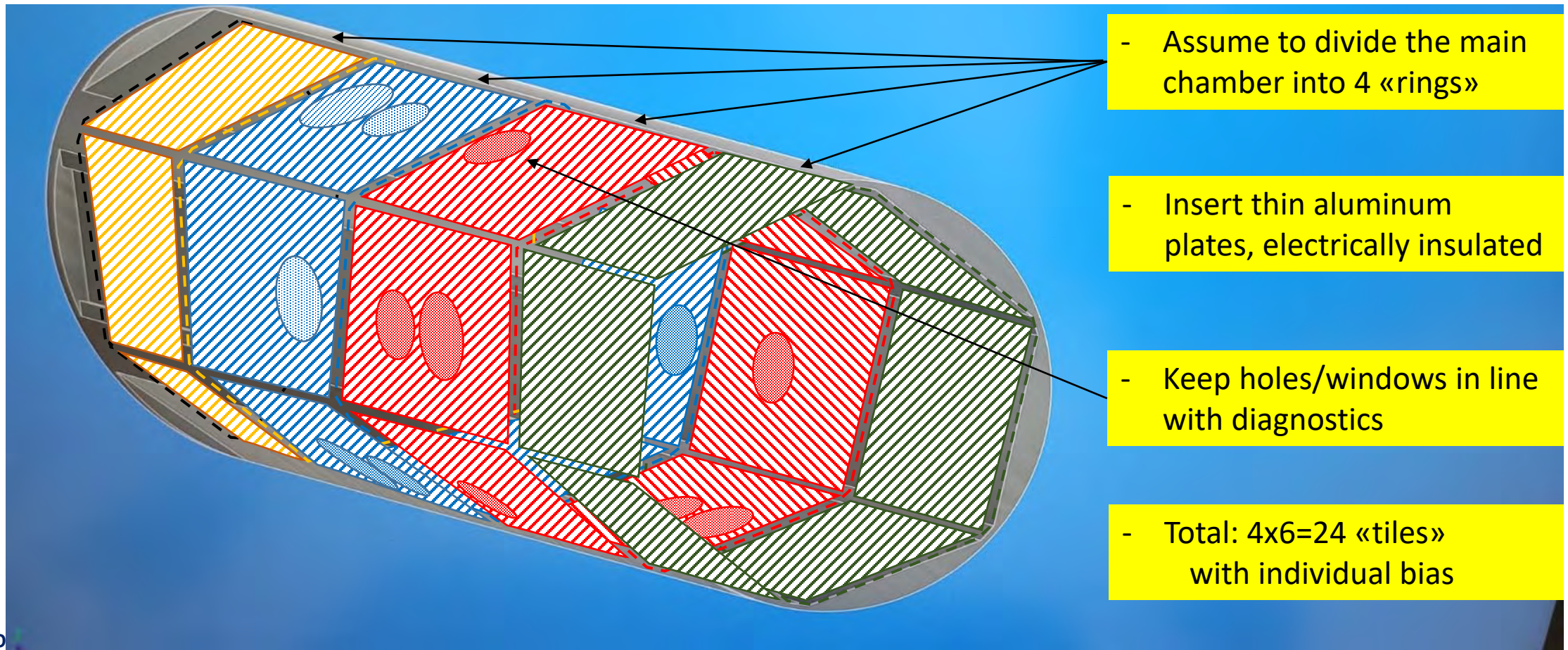
Baking	Tmax (ring3 tail1)	Pressure @ T <sub>ambient</sub>
30 W	115°C	2.5x10E-6
38 W	127°C	1.0x10E-6
42 W	135°C	8.6x10E-7
51-61 W	145-155°C	7.4x10E-7
51-61 W	145-155°C	<b>4.6x10E-7 after 3h pumping</b>

# Electrical test before and after baking

Electrical insulation among tails has been tested up to 100V, before and after baking  
➔ Insulation is stable

# Active Plasma Inner Chamber: design options for the PANDORA apparatus

The design of the Main Plasma Chamber is ongoing (LNS + INFN-PD): design could change from a cylindrical geometry to an extrusion of a hexagonal section → this geometry simplifies a lot the integration of detectors and of the Plasma Inner Chamber. The final design will be possible only when the technical specifications (dimensions) of the magnetic trap will be known.

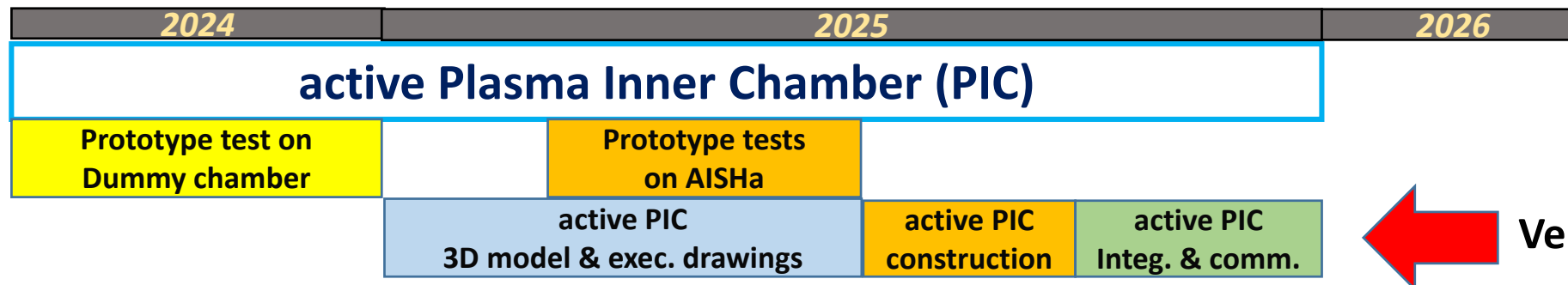


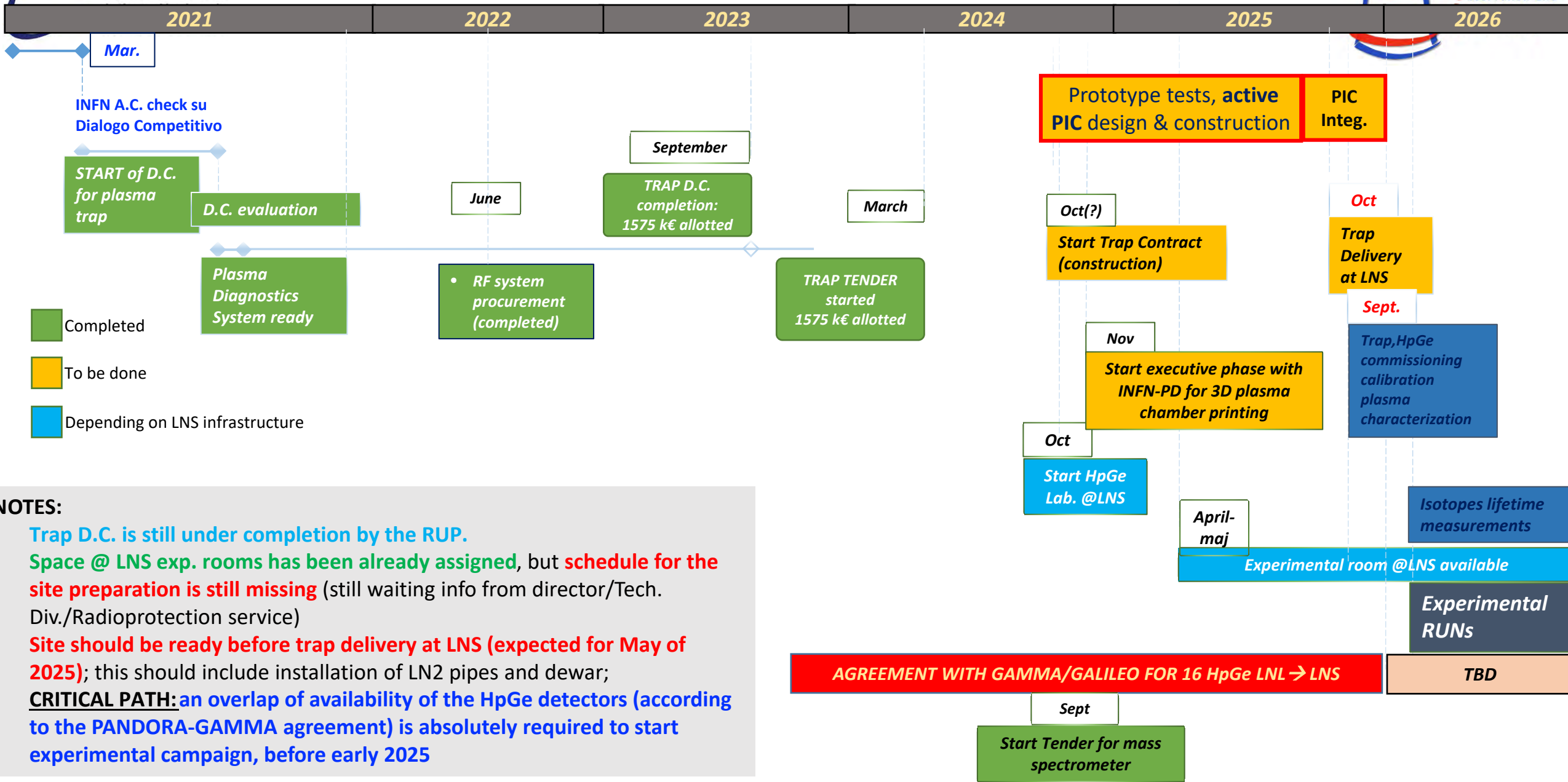


# Next activity & Timeline

We would have results from prototype tests on AISHa before the PIC final design for PANDORA

PERIOD	NEXT ACTIVITY	RESP.	COMMENTS
nov-dec 2024	Prototype of active chamber: test on dummy ch.	BO & LNS	Emulate AISHa cooling
mar-july 2025	Prototype of active chamber: tests on AISHA	LNS & BO	Integration with AISHa
jan-feb 2025	PANDORA Active Plasma Inner Chamber: 3D model	BO & LNS & LNL	Integration with Trap design
mar-jul 2025	PANDORA Active PIC: executive drawings	BO	Integration with Trap design
aug-oct 2025	PANDORA Active PIC: construction	BO	
nov-dec 2025	PANDORA Active PIC: integration & test	LNS & BO	Integration & Commissioning





**NOTES:**

- Trap D.C. is still under completion by the RUP.
- Space @ LNS exp. rooms has been already assigned, but **schedule for the site preparation is still missing** (still waiting info from director/Tech. Div./Radioprotection service)
- Site should be ready before trap delivery at LNS (expected for May of 2025)**; this should include installation of LN2 pipes and dewar;
- CRITICAL PATH:** an overlap of availability of the HpGe detectors (according to the PANDORA-GAMMA agreement) is absolutely required to start experimental campaign, before early 2025

Thank you  
for your attention!